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APPLICANTS

Katsutoshi Izumi, Osaka, JAPAN;

Motoi Nakao, Osaka, JAPAN;
Yoshiaki Ohbayashi, Nara-shi, JAPAN; Keiji Mine, Osaka, JAPAN;
Seisaku Hirai, Osaka, JAPAN;
Fumihiko Jobe, Osaka, JAPAN;
Tomoyuki Tanaka, Osaka, JAPAN;

** CONTINUING DATA *****

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** FOREIGN APPLICATIONS *****

JAPAN 2002-022631 01/31/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>			

ADDRESS

23850
ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP
1725 K STREET, NW
SUITE 1000
WASHINGTON, DC
20006

TITLE

Manufacturing apparatus for buried insulating layer-type semiconductor silicon carbide substrate

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